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Irena Nikolova

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In Re Application of:

Yuji Okuda

Confirmation No.: 1643

Serial No: 10/018,708

Group Art Unit: 3723

Filed: April 15, 2002

Examiner: Wilson, Lee D

For: TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISHING SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Final Office Action dated March 31, 2005, please amend the above-identified application in the following manner:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

